



ALTERNATIVE TO PTO/SB/08A/B (09/06)

Substitute for form 1449/PTO		Complete If Known	
INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Use as many sheets as necessary)		Application Number	10/589275
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		First Named Inventor	Regnier
		Art Unit	2873 2811
		Examiner Name	Not Yet Assigned J. Im
Sheet 1 of 1	Attorney Docket Number	61919-24uspx	

U.S. PATENT DOCUMENTS				
Examiner Initials*	Cite No. ¹	Document Number Number-Kind Code ² (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document
/JH/	A1*	US-2002/068430 A1	06-06-2002	Eldridge.
	A2	US-5,666,000 A	09-09-1997	Dusablon et al.
	A3	US-2003/234423 A1	12-25-2003	Bul et al.
	A4	US-5,296,408 A	03-22-1994	Wilbarg, et al.

FOREIGN PATENT DOCUMENTS				
Examiner Initials*	Cite No. ¹	Foreign Patent Document Country Code ³ -Number ⁴ -Kind Code ⁵ (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document
/JH/	B1	EP 1191557 A	03-27-2002	Bosch
	B2	WO 03/103029	12-11-2003	Ericsson
	B3	EP 1209738 A	05-29-2002	Chartered Semiconductor

*EXAMINER: Initial if information considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. ¹ Applicant's unique citation designation number (optional). ² See Kinds Codes of USPTO Patent Documents at www.uspto.gov or MPEP 901.04. ³ Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). ⁴ For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵ Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. *Applicant is to place a check mark here if English language Translation is attached.

NON PATENT LITERATURE DOCUMENTS				
Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.		
/JH/	C1	Sugiyama, et al. "Micron-diaphragm pressure sensor" International Electron Devices Meeting, Dec. 7, 1986 pages 184-187 XP002039418		
/JH/	C2	International Search Report from PCT/FR2005/000318 dated May 31, 2005.		

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Examiner Signature	/Junghwa Im/	Date Considered	11/22/2009
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